

**Notice of References Cited**

Application/Control No.

10/824,719

Applicant(s)/Patent Under

Reexamination

SCHUBERT ET AL.

Examiner

Tony Chuo

Art Unit

1795

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0016769	01-2004	Redmond, Scott D.	222/3
*	B	US-2003/0170939	09-2003	Yamazaki et al.	438/166
*	C	US-2002/0158284	10-2002	Kim, Hyeon-Seag	257/316
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
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	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	P					
	Q					
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**NON-PATENT DOCUMENTS**

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